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PATENT APPLICATION

L. PHAM

119222

Group Art Unit: 2814

Examiner:

Docket No.:

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Junichi KARASAWA et al.

Application No.: 10/807,288

Filed: March 24, 2004

arch 24 2004

For: FERROELECTRIC LAYER, METHOD OF MANUFACTURING FERROELECTRIC LAYER, FERROELECTRIC CAPACITOR, AND FERROELECTRIC MEMORY

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the May 18, 2005 Restriction Requirement, Applicants provisionally elect Group II, claims 3-12, with traverse.

It is respectfully submitted that the subject matter of all claims 1-18 are sufficiently related that a thorough search for the subject matter of any one Group of claims would encompass a search for the subject matter of the remaining claims. Thus, it is respectfully submitted that the search and examination of the entire application could be made without serious burden. See MPEP §803 in which it is stated that "if the search and examination of an entire application can be made without serious burden, the examiner must examine it on the merits, even though it includes claims to independent or distinct inventions" (emphasis added). It is respectfully submitted that this policy should apply in the present application in order to avoid unnecessary delay and expense to Applicants and duplicative examination by the Patent Office.

Thus, withdrawal of the Restriction Requirement is respectfully requested.

Respectfully submitted,

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JAO:LMS/hs

Date: June 2, 2005

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